

The Optical Properties of Sb Doped SnO₂ Thin Film Produced by Spin Coating

Şilan BATURAY¹, Serap YIGIT GEZGIN², Hamdi Sukur KILIC^{2,3,4}

¹Department of Physics, Faculty of Science, Dicle University, 21280 Diyarbakir, Turkey

²Department of Physics, Faculty of Science, University of Selçuk, 42031 Selçuklu, Konya, Turkey

³Directorate of High Technology Research and Application Center, University of Selçuk, 42031 Selçuklu, Konya, Turkey

⁴Directorate of Laser Induced Proton Therapy Application and Research Center, University of Selçuk, 42031 Konya, Turkey

Abstract – In this study, there is investigated that the optical properties of the 0%, 1%, 2%, and 3% Sb doped SnO₂ thin films produced by spin coating technique. The photon absorption of 3% Sb doped SnO₂ thin film is very high while the non-doped and 2% Sb doped SnO₂ thin films have low absorption and are close to each other. The extinction coefficient of thin films was calculated and its graph was plotted depend wavelength. Refraction indices and dielectric coefficients were calculated and the results interpreted using Herve&Vandamme, Moss and Ravindra relations. The Skin Depth and the optical conductivity characterizes depend band gap of all thin films are drawn and explained.

Keywords –Sb Doped SnO₂, Thin Film, Refraction Indices, Skin Depth, Extinction Coefficient

1. Introduction

Tin oxide (SnO₂) thin films, which are transparent conducting materials have found widespread use in gas-sensing performance [1], chemical sensors to H₂S [2], UV-B sensors [3], ozone sensors [4], dilute hydrogen sulfide sensing [5], LPG detection [6], and photoemission detection [7] Tin oxide is one of the best materials for various applications owing to its unique physical features. Because of the favorable features of tin oxide (SnO₂), numerous researchers have studied non-doped and doped SnO₂ thin films [8, 9]. In the reports obtained so far, SnO₂ samples formed using different physical and chemical samples deposition techniques; spray deposited

[10], sol-gel fabrication process [11], pulsed laser process [12], reactively sputtered [9], and spin coating [13]. Spin coating deposition is the best method for producing tin oxide coated soda lime glass substrates with good optical transmission and low sheet resistance.

SnO₂ is an important semiconducting material with a typical *n*-type direct wide band gap (E_g3.6 eV at 300 K) [14]. It has some interesting properties, including; chemically inert, mechanically durable, and heat resistant [15]. Dopants such as zirconium [13], fluorine [16], cobalt [17], manganese [18], and titanium [19] are used to enhance the electrical, structural and optical characteristics of SnO₂ thin

films. Spin coating process has recently produced low resistivity and high mobility antimony-doped SnO₂ thin film, which exhibits much improved electrical stability than un-doped samples [20]. Gürakar et. al indicated that the optical band gap value, the dielectric constant, and the optical conductivity changes with Sb doping ratio in solution.

There are very few studies in the literature on the characterization of SnO₂ thin films compared to semiconductor thin films such as In₂O₃, ZnO and CuO₂. However, doping significantly changes the structural and surface properties of the SnO₂ thin film. Although there are studies on SnO₂ thin films; there is limited information about the effects on the optical properties of different Sb-doping in SnO₂ thin films obtained using the spin coating process,

2. Experimental



Fig 1. Systematic illustration of Sb:SnO₂ thin film

The pure and antimony doped SnO₂ films were successfully grown on glass substrate using spin coating an aqueous solution of 0.1M tin(II) chloride dehydrate and 0.01 M antimony trichloride (SbCl₃) as sources of tin and antimony ions, respectively. Antimony trichloride was used for Sb doping with changed concentrations (1, 2, and 3 at% Sb). Glass substrate washing technique is very

and Sb-doped SnO₂ samples obtained by the spin coating have not been investigated in detail to date. For this reason, pure and antimony doped SnO₂ films were prepared using spin coating technology in the study. The effects of antimony ions at different concentrations in SnO₂ was detailed discussed. Depending on the various doping concentrations ratio, the optical, characteristics of these films were detailed determined. The optical properties films were evaluated related to the energy band gap, absorbance, the refractive index, the high frequency dielectric constant-(ϵ_{∞}) and the static dielectric constant-(ϵ_0), the Urbach energy, optical conductivity, and skin depth value of the films using UV-Vis spectrophotometer in the 300-1100 nm wavelength at room temperature.

significant procedure in the manufacture of high quality samples because of the fact that the contamination on the surface of the glass substrate negatively effects quality of the thin film growing and cracking. Therefore, before deposition process, soda lime glass substrates firstly washed with detergent and stirred in ethanol. After obtaining the Sb:SnO₂ solutions and washing process, the films

were then spin coating process at the spin rate of 2000 rpm for 63 s and the acquire solutions were grown on the cleaned substrate for 10 layers of deposition and each layer was heated 220 °C. Having obtained the 10 layers of coating (about 450 nm thickness), all the obtained samples annealed at 450 °C for 1h at a quartz furnace to gain crystal

phase in XRD spectra. The conclusion of the energy band gap, absorbance, the refractive index, The high frequency dielectric constant-(ϵ_{∞}) and the static dielectric constant-(ϵ_0), the Urbach energy, optical conductivity, and skin depth value of the films was analyzed using UV-Vis spectrophotometer in the 300-1100 nm wavelength.

3. Optical Properties of the non-doped and Sb:SnO₂ thin films

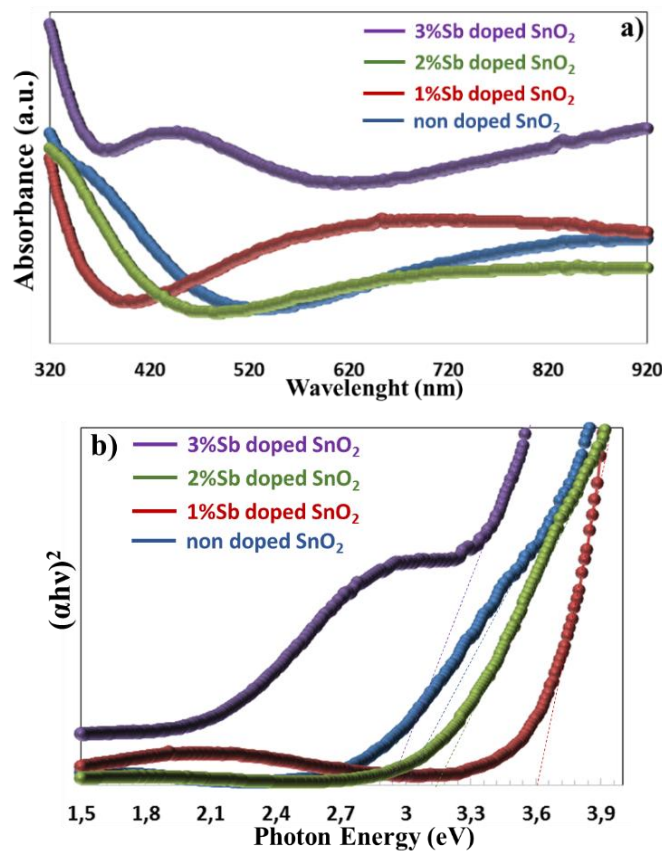


Fig. 2. a) The absorption spectrum and b) the energy band curve of the Sb:SnO₂

In this study, 3% Sb doped SnO₂ thin film absorbs a high amount of photons. The non-doped and 2% Sb doped SnO₂ samples are close to each other and have low photon absorption according to Fig. 2a. 1% Sb doped SnO₂ sample absorbs high photons towards the near infrared region. The non-doped, 2%, and 3% Sb doped SnO₂ samples tend to have low photon absorption in the visible region. The

energy band gap graph in Fig. 2b which was obtained using $\alpha h\nu = A(h\nu - E_g)^{1/2}$ Tauc equation [21]. The band gaps of the 0%, 1%, 2%, and 3% Sb doped SnO₂ samples are 3.00 eV, 3.60 eV, 3.14 eV and 2.90 eV, respectively.

The refractive index of semiconductors used as *n*-type buffer layers in the solar cells that is of great importance in terms of photovoltaic performance.

Three different methods were used in this study to calculate the refractive index safely and accurately. First, the refractive index (n) was calculated using the Moss relations given in Equation (Eq.)1:

$$E_g n^4 = k \quad (1)$$

k is a constant and has a value of 108 eV. The results obtained for all thin films are given in Table 1. Although the refractive indices of thin films are generally low, the lowest refractive index belongs to 1% Sb doped CuO thin film. In order to transmit the light more to the absorbing layer, this refractive indices value is more ideal than other thin films in terms of buffer layer n-type semiconductor.

To verify the refractive indices calculated with Moss relation, the calculations were also made with Herve and Vandamme relation in Eq.(2) [21]:

$$n = \sqrt{1 + \left(\frac{A}{E_g + B}\right)^2} \quad (2)$$

A constant that is 13.6 eV and B constant that is 3.4 eV. The refractive indices calculated with this relation were found to be lower compared to Moss relation. In addition to these two relations, the refractive indices are determined with Ravindra given in Eq. (3) are presented [22] in Table 1.

$$n = 4.16 - 0.85E_g \quad (3)$$

If these three relationships are compared, Moss and Herve&Vandamme relations present results that are closer to each other. Ravindra relation led to the lowest values.

The dielectric coefficient is defined by the electrical field that ensures charge separation and transition in thin films. This charge separation enables significant charge concentration in solar cells. The high frequency dielectric constant-(ϵ_∞) and the static dielectric constant-(ϵ_o) which are expressed by Eq. (3) and Eq. (4), respectively[21]:

$$\epsilon_\infty = n^2 \quad (4)$$

$$\epsilon_o = 18.52 - 3.08E_g \quad (5)$$

ϵ_∞ and ϵ_o values for the non-doped and Sb doped SnO₂ thin films that are given in Table 1. Accordingly, the dielectric coefficients of thin films with low band gap are high. Furthermore, the size of the refractive index of the thin film is a factor that increases the dielectric coefficient. As a result, thin film 3% Sb doped SnO₂ thin film showed the highest the refractive indices and dielectric coefficient, while 1% Sb doped SnO₂ thin film presented the lowest diffraction and dielectric coefficient.

Table 1. Refractive index (n), high frequency dielectric constant (ϵ_∞) and static dielectric constant (ϵ_o) of the nondoped and Sb doped SnO₂ thin films

Samples	E_g (eV)	Moss relation		Herve&Vandamme		Ravindra		Static Dielectric Constant, ϵ_o
		n	ϵ_∞	n	ϵ_∞	n	ϵ_∞	
Non-doped SnO ₂	3.00	2.44	6.25	2.34	5.47	1.61	2.59	9.28
1%Sb doped SnO ₂	3.60	2.34	5.47	2.18	4.75	1.10	1.21	7.43
2%Sb doped SnO ₂	3.14	2.42	5.85	2.30	5.29	1.50	2.25	8.84
3%Sb doped SnO ₂	2.90	2.47	6.10	2.38	5.66	1.70	2.89	9.58

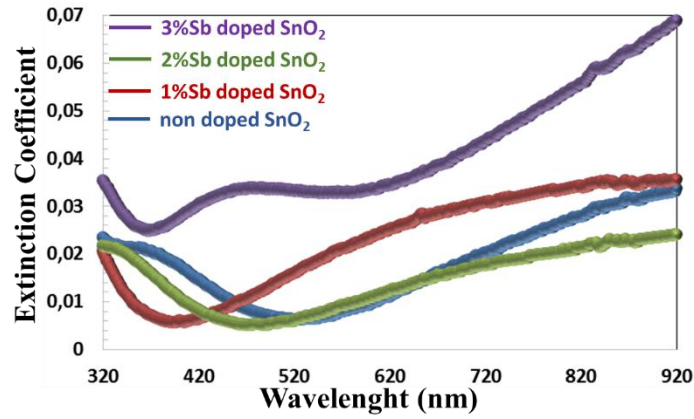


Fig. 3. Extinction coefficient spectra of the non-doped and Sb:SnO₂ thin films

The extinction coefficient is an important parameter for thin films used in solar cells. Light entering the thin film is either absorbed or scattered, depending on particle size, density or defect status. This situation can be defined as the extinction. The extinction coefficient of n-type semiconductors used as buffer layers in solar cells must be low in order to transmit more light. The extinction coefficient (k) is obtained by Eq. (6) [23, 24]:

$$k = \frac{\alpha\lambda}{4\pi} \quad (6)$$

λ is the wavelength number of the light. The absorption coefficient of the thin film is defined as

$\alpha = 2.303(A/T)$ [25]. Here, A is the absorbance and T is the thickness of the thin film. According to the wavelength-dependent extinction coefficient spectrum (in Fig. 3) drawn using Eq. (6), while 3% Sb doped SnO₂ thin film shows a high extinction coefficient peak at wavelength 474 nm in the visible region, non-doped SnO₂, 1% Sb, %2 Sb doped SnO₂ thin films exhibit low k values on 539 nm (visible region), 398 nm (ultraviolet region), 477 nm (visible region) wavelength, respectively. All films tend to have high photon absorption in the near-infrared region.

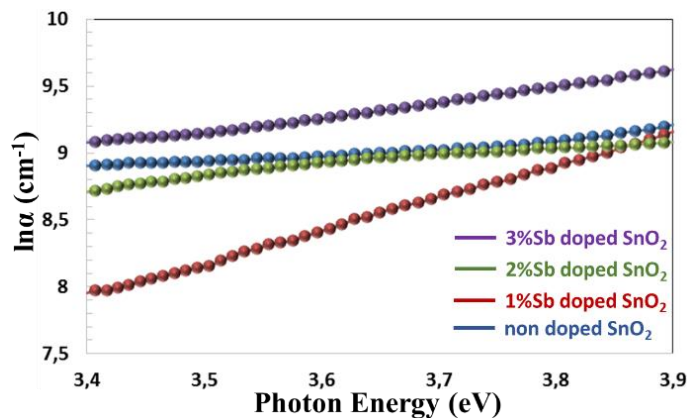


Fig. 4. The Urbach energy of the non-doped and Sb doped SnO₂ thin films

Urbach energy (E_U) describes material disorder as transitions between localized conduction band states

and extended valence band states. Eq. (7), as interpreted below, may be used to determine the

disorder in the chemical based on the change in the absorption coefficient.

$$\alpha = \alpha_o \exp(h\nu/E_U) \quad (7)$$

where α_o is a constant. E_U energy was obtained by slope of $(\ln\alpha)$ versus $(h\nu)$ in Fig. 4. E_U values of the non-doped SnO₂, 1% Sb doped SnO₂, 2% Sb doped SnO₂ and 3% Sb doped SnO₂ thin films are 0.75 eV, 2.38 eV, 0.47 eV and 1.21 eV, respectively.

Thin films' Urbach energy grow as their band gap decreases. The high Urbach energy value of 1% Sb doped SnO₂ thin film point to more phonon disorder matched to other Sb doped SnO₂ samples. In addition, the high Urbach energy value may be lead to stoichiometric deviation, the distortion in the obtained sample increasing the band tail [26, 27] and localized states density value in the obtained samples [28].

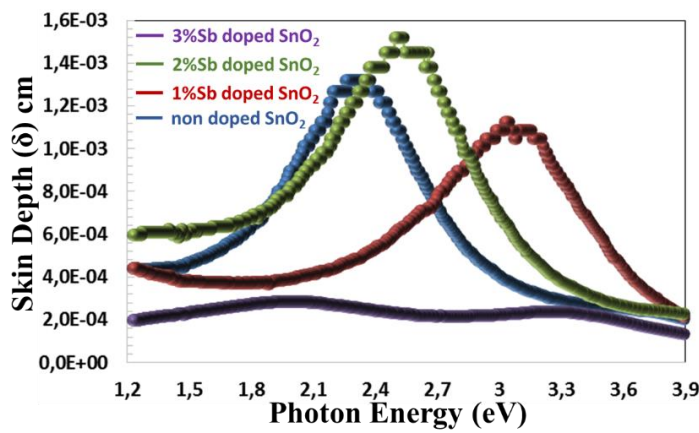


Fig. 5. Skin Depth spectra of the non-doped and Sb:SnO₂ thin films

Depending on the size, shape, number of particles and thickness of the particles that make up the thin film, light incident on the thin film travels to a certain position within the thin film. This distance taken is expressed as Skin depth (χ) [24]. χ parameters of the thin films that is defined by Eq. (8);

$$\chi = \frac{\lambda}{2\pi k} \quad (8)$$

According to Fig. 5, the skin depths of the 0%, 1%, 2%, and 3% Sb doped SnO₂ are 0.0013 cm, 0.0011cm, 0.0015 cm and 0.00028 in 2.25 eV, 3.04 eV, 2.52 eV, 2.00 eV, respectively. The light coming from this band range will be able to diffuse through the thin films and go out easily. In solar cells, this is a good factor so that the light transmission can reach the absorber layer without being restricted.

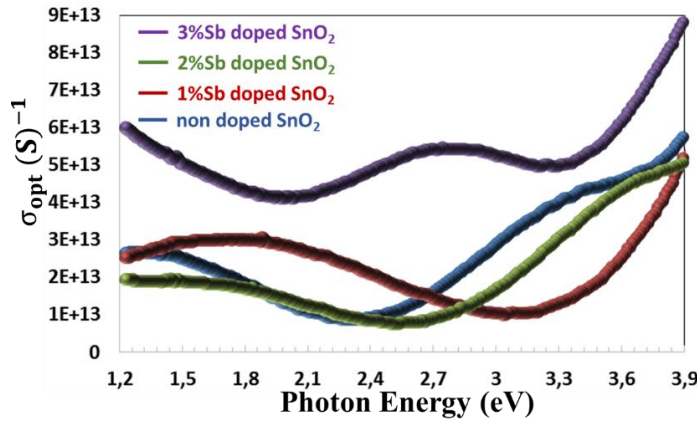


Fig. 6. The optical conductivity ($\sigma_{opt}(S)^{-1}$) spectra of the Urbach energy of the non-doped and Sb doped SnO₂ thin films

The optical conductivity (σ_{opt}) of the non-doped and Sb doped SnO₂ thin films is calculated by Eq. (9);

$$\sigma_{opt} = \frac{\alpha mc}{4\pi} \quad (9)$$

where c is that the light speed. Value of σ_{opt} defines the density of photo excited electrons [26, 29]. (σ_{opt})-photon energy curve of the non-doped and Sb doped SnO₂ thin films that are given as seen in Fig. 6. The highest optical conductivity is presented in 3% Sb doped SnO₂ thin film. However, this feature is more common in p -type semiconductors. The lowest optical conductivity was observed in 2% Sb doped SnO₂ thin film. All thin films exhibited optical conductivity compatible with their band gap.

4. Conclusions

In this study, the band gaps of the non-doped SnO₂, 1% Sb doped SnO₂, 2% Sb doped SnO₂ and 3% Sb doped SnO₂ thin films produced by spin coating technique that are 3.00 eV, 3.60 eV, 3.14 eV and 2.90 eV, respectively. The refractive indices calculated with Herve&Vandemme relation were found to be lower compared to Moss relation. Ravindra relation led to the lowest values. thin film 3%Sb doped SnO₂ thin film showed the highest the

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